

SLOVENSKI STANDARD kSIST FprEN ISO 21670:2014

01-februar-2014

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Fasteners - Hexagon weld nuts with flange (ISO/FDIS 21670:2013)

Sechskant-Schweißmuttern mit Flansch (ISO 21670:2013)

Fixations - Écrous hexagonaux à souder, à embase plate (ISO/FDIS 21670:2013)

Ta slovenski standard je istoveten z: FprEN ISO 21670

ICS:

21.060.20 Matice Nuts

kSIST FprEN ISO 21670:2014 en,de

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FINAL DRAFT

INTERNATIONAL STANDARD

ISO/FDIS 21670

ISO/TC 2/SC 12

Secretariat: DIN

Voting begins on: **2013-12-12**

Voting terminates on:

2014-02-12

Fasteners — Hexagon weld nuts with flange

Fixations — Écrous hexagonaux à souder, à embase plate

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Please see the administrative notes on page iii



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ISO/FDIS 21670:2014(E)



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ISO/CEN PARALLEL PROCESSING

This final draft has been developed within the International Organization for Standardization (ISO), and processed under the **ISO-lead** mode of collaboration as defined in the Vienna Agreement. The final draft was established on the basis of comments received during a parallel enquiry on the draft.

This final draft is hereby submitted to the ISO member bodies and to the CEN member bodies for a parallel two-month approval vote in ISO and formal vote in CEN.

Positive votes shall not be accompanied by comments.

Negative votes shall be accompanied by the relevant technical reasons.

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2. www.iso.org/directives

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For an explanation on the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the WTO principles in the Technical Barriers to Trade (TBT) see the following URL: Foreword - Supplementary information

The committee responsible for this document is ISO/TC 2, *Fasteners*, Subcommittee SC 12, *Fasteners* with metric internal thread.

This second edition cancels and replaces the first edition (ISO 21670:2003), of which it constitutes a minor revision.

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